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18 May 2004
Date of Deposit

Paul E. Rauch, Ph.D.
Name of Applicant, Assignee or
Registered Representative

[Signature]
Signature

Our File No.: CYP01-002-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: H. Bamnolker et al.

Serial No.: 09/927,863

Filing Date: August 10, 2001

For: METHODS OF FORMING
SEMICONDUCTOR STRUCTURES HAVING
REDUCED DEFECTS, AND ARTICLES AND
DEVICES FORMED THEREBY

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)
) Examiner: Lynette T. Umez-Eronini
)
) Group Art Unit No.: 1765
)
)
)

TRANSMITTAL

M.S. - AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is:

- ☒ Credit Card Form
- ☒ Two Month Extension of Time (in duplicate)
- ☒ Request for Reconsideration
- ☒ No additional fee is required.
- ☒ The Commissioner is hereby authorized to charge any fees associated with this communication not covered by check or credit card payment or credit any overpayment to Deposit Account No. 50-3123. A duplicate copy of this sheet is attached.

Respectfully submitted,

[Signature]

Paul E. Rauch, Ph.D.
Registration No. 38,591

Evan Law Group LLC
566 West Adams
Suite 350
Chicago, Illinois 60661
(312) 876-1400